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Serial Number: **10/814.165**

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- 2) See attached EAST Inventor Search
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Day : Monday
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 **PALM INTRANET**

Inventor Information for 10/814165

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US 6932115 B2	20050823	Valve apparatus for hermetic compressor	137/857	137/855; 417/569	Kim; Tae- Min et al.
US 6716001 B2	20040406	Oil supply apparatus for hermetic compressor	417/363	417/366; 417/415; 417/424.2; 417/902	Kim; Tae- Min
US 6626648 B1	20030930	Apparatus for noise depreciating in hermetic compressor	417/312	181/229; 181/230; 181/403	Kim; Tae- Min
US 6252640 B1	20010626	Method for manufacturing a wide band polarization film	349/96	349/175; 349/185; 349/187	Kim; Sung Tae et al.
US 6206135 B1	20010327	Suction noise muffler for hermetic compressor	181/229		Kim; Tae Min et al.
US 5908287 A	19990601	Suction noise muffler mounting apparatus for hermetic compressor	417/312	181/229; 417/902	Kim; Tae Min et al.
US 5906477 A	19990525	Suction noise muffler mounting apparatus for hermetic compressor	417/312	181/229; 181/403; 417/902	Kim; Tae Min et al.
US 5804777 A	19980908	Suction noise muffler for hermetic compressor	181/229	181/236; 181/264; 181/282; 181/403	Kim; Tae Min et al.
US 5800768 A	19980901	Method for thermally treating electroconductive polymeric pyrogen	264/450	264/105; 264/235; 264/346; 264/452; 264/477	Kim; Tae Min et al.
US 5707216 A	19980113	Suction noise muffler mounting apparatus for hermetic compressor	417/312	181/229; 181/403	Kim; Tae Min et al.